Reconsideration of this application and the allowance of rejected claims 1-3

and 5-7 are respectfully requested. Applicants have attempted to address all grounds for

rejection in the Office Action dated October 20, 2009 (Paper No. 20091014) and believe that

the application is now in condition for allowance. The claims have been amended to more

clearly describe the present invention.

Claims 1, 3, and 5 are rejected under 35 U.S.C. § 103(a) as being unpatentable

over the combination of U.S. Patent No. 6,066,598 to Ishikawa et al. and U.S. Patent No.

5,834,405 to Ahn et al. Applicants disagree with and traverse this rejection for the following

reasons.

Ishikawa discloses a superconducting multilayer electrode including alternating

superconductor layers 1, 2, 3, 4 and 5, and thin-film dielectric layers 30-1, 30-2, 30-3 and 30-

4 laminated with each other on one side of a dielectric substrate 10 as shown in Fig. 1. The

superconductor layer 5 is formed on the substrate 10 and then the dielectric layers and

superconductor layers are alternately laminated thereon.

Ahn discloses a superconducting multilayer ceramic substrate that is prepared

by connecting at least one metallic conductor embedded in a ceramic dielectric oxide before

establishing a superconducting oxide reaction layer at intervals between the ceramic material

and at least one metallic conductor.

In contrast, amended claim 1 recites, among other things, a method for

producing a superconducting inductive component that includes the steps of "depositing an

insulating film directly on a substrate and depositing a stack of alternately superconducting

and insulating films comprising at least one line segment incorporating at least one terminal

of the component on said insulating film, said line segment including one of a conducting

layer and a superconducting layer." The combination of Ishikawa and Ahn fails to disclose or

suggest such subject matter.

As stated above, Ishikawa discloses a superconducting multilayer or electrode

including alternating superconductor layers and thin-film dielectric layers (i.e., insulating

layers). As shown in Fig. 1, the bottommost layer of the stack is a superconducting layer 5

that is directly deposited on the substrate 10. In fact, Ishikawa specifically states that "a

superconducting multilayer electrode is formed on the top surface of a dielectric substrate 10

having a ground conductor 11 formed on the bottom surface thereof so as to come into

contact with a thin-film superconductor 5 which is the bottommost layer" (Col. 3, lines

59-63). The electrode is structured this way to form a TEM mode microstrip line LN10.

Ishikawa therefore fails to discloses a superconducting component on which an insulating

film is deposited directly on a substrate and then a stack of alternatively superconducting

insulating films are deposited on that film as recited in amended claim 1.

Ahn does not remedy the deficiencies the Ishikawa. Ahn discloses a

superconducting multilayer ceramic substrate and a method for producing that substrate.

Ahn does not disclose or suggest depositing an insulting film directly on that substrate or

depositing a stack of alternatively superconducting and insulating films on the substrate.

Clearly, Applicants' submit that amended claim 1, and the claims that depend therefrom, are

each patentably distinguished over the combination of Ishikawa and Ahn and in condition for

allowance.

New claim 32 depends from amended claim 1 and recites, among other things,

that "the superconducting inductive component operates at a high inductance that is obtained

at frequencies equal to or less than 2000 Hz." (The subject matter of this claim is supported in

Fig. 6 and on page 8, line 15 through page 9, line 2.) Thus, the component produced by the

method described in amended claim 1 has a high inductance that is obtained at very low

frequencies.

Ishikawa, on the other hand, is directed a superconducting multilayer electrode

for use in high-frequency bands including microwaves, decimillimetric waves, or millimetric

wave, for use in devices such as high-frequency transmission lines, resonators and filters

(Col. 1, lines 7-12). For example, the superconducting material described in Ishikawa is for

use in a microwave frequency band of 10 Hz.

Ahn describes a superconducting substrate formed by embedding a metallic

conductor in a ceramic dielectric oxide. The substrates are intended for use supercomputers

that operate in a standby mode at normal operating temperatures. Also Ahn operates at

frequencies that are consistent with computer boards, i.e., approximately 400 MHz. The

components disclosed by Ishikawa and Ahn are therefore meant to operate at frequencies that

are significantly greater than the frequencies of the components disclosed in new claim 32.

Accordingly, Applicants submit that new claim 32 is patentably distinguished over the

combination of Ishikawa and Ahn and in condition for allowance.

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Claim 2 is rejected under 35 U.S.C. § 103(a) as being unpatentable over the

combination of Ishikawa, Ahn and "IEEE Transactions on Magnetics," 27:1365-1368 (1991)

to Lee et al. Applicants disagree with and traverse this rejection for the following reasons.

Claim 2 depends from amended claim 1. As stated above, the combination of

Ishikawa and Ahn fails to disclose or suggest the subject matter of amended claim 1. Lee

fails to remedy the deficiencies of Ishikawa and Ahn. Therefore, Applicants submit that

claim 2 is patentably distinguished over the combination of Ishikawa, Ahn and Lee for at

least the reasons provided above and for the further reasons that the cited combination fails to

disclose or suggest the subject matter of claim 2 in combination with the subject matter of

amended claim 1.

Claims 6 and 7 are rejected under 35 U.S.C. § 103(a) as being unpatentable

over the combination of Ishikawa, Ahn and U.S. Patent No. 5,219,827 to Higaki. Applicants

disagree with and traverse this rejection for the following reasons.

Claim 6 depends from amended claim 1. Claim 7 depends from claim 5 which

depends from amended claim 1. As stated above, the combination of Ishikawa and Ahn fails

to disclose or suggest the subject matter of amended claim 1. Higaki fails to remedy the

deficiencies of Ishikawa and Ahn. Therefore, Applicants submit that claims 6 and 7 are each

patentably distinguished over the combination of Ishikawa, Ahn and Higaki for the reasons

provided above and for the further reason that the cited combination fails to disclose or

suggest the subject matter of claims 6 and 7 in combination with the subject matter of

amended claim 1.

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In view of the above remarks, the application is respectfully submitted to be in

allowable form. Allowance of the rejected claims is respectfully requested. In the

alternative, the claims are placed in a better form for appeal. Should the Examiner discover

there are remaining issues which may be resolved by a telephone interview, he is invited to

contact Applicants' undersigned attorney at the telephone number listed below.

Respectfully submitted,

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